AMENDMENTS TO THE CLAIMS

Cancel claims 1 to 7 without prejudice. Please accept amended claims 8, 14, 16, 18 and 20 as follows:

1-7. (Cancelled)

8. (Original) A method for preparing an alignment layer surface, comprising the steps of:

providing a surface on the alignment layer;

bombarding the surface with ions; and

quenching the surface with a reactive component to saturate dangling bonds on the surface.

- 9. (Original) The method as recited in claim 8, wherein the alignment layer includes diamond like carbon.
- 10. (Original) The method as recited in claim 8, wherein the step of quenching the surface with a reactive component includes the step of quenching the surface with a reactive gas to saturate dangling bonds on the surface.
- 11. (Original) The method as recited in claim 10, wherein the reactive gas includes at least one of hydrogen, nitrogen, carbon dioxide, oxygen and water vapor.

- 12. (Original) The method as recited in claim 8, wherein the step of quenching the surface with a reactive component includes the step of quenching the surface with a reactive liquid to saturate dangling bonds on the surface.
- 13. (Original) The method as recited in claim 12, wherein the reactive liquid includes at least one of alcohol, water, hydrogen peroxide, carbon dioxide-saturated water, and liquid crystal.
- 14. (Currently Amended) A method for preparing an alignment layer surface for liquid crystal displays, comprising the steps of:

providing a diamond like carbon surface;

bombarding the surface with ions from an ion beam;

saturating dangling bonds on the surface caused by the bombarding step; and quenching the surface with a reactive component to saturate dangling bonds on the surface.

- 15. (Original) The method as recited in claim 14, wherein the step of bombarding includes the step of introducing a reactive gas to the ion beam.
- 16. (Currently Amended) The method as recited in claim [[14]] 15, wherein the reactive gas includes at least one of [[nitrogen, hydrogen, oxygen, fluorine]] silane [[and]] or tetrafluoromethane.

- 17. (Original) The method as recited in claim 14, wherein the step of bombarding the surface with ions includes the step of bombarding the surface with Argon ions and reactive gas ions.
- 18. (Currently Amended) The method as recited in claim 14, wherein the [[step of saturating dangling bonds includes the step of quenching the surface with]] reactive component is a reactive gas [[to saturate dangling bonds on the surface]].
- 19. (Original) The method as recited in claim 18, wherein the reactive gas includes at least one of hydrogen, nitrogen, carbon dioxide, oxygen and water vapor.
- 20. (Currently Amended) The method as recited in claim 14, wherein the [[step of saturating dangling bonds includes the step of quenching the surface with]] reactive component is a reactive liquid [[to saturate dangling bonds on the surface]].
- 21. (Original) The method as recited in claim 20, wherein the reactive liquid includes at least one of alcohol, water, hydrogen peroxide, carbon dioxide-saturated water, and liquid crystal.